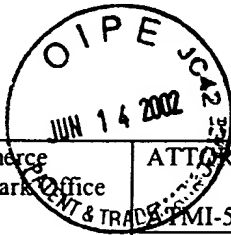


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INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Ying Ma, et al.			
				FILING DATE August 23, 2001		GROUP 172 1763	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
gag	AA	6,409,781	6-25-02	Thomas H. Baum, et al.			5/1/2000
	AB	6,117,775	9/12/2000	Kondo, et al.			
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	AE	6,232,231	5/15/2001	Sethuraman, et al.			
	AF	5,985,748	11/16/99	Watts, et al.			
	AG						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
gag	AH	01/23486	4/5/2001	World ✓			abstract (only)
OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)							
	A*	Shyama P. Mukherjee, et al., Mat. Research Soc. Symp. Vol. 613, "Planarization of Copper Damascene Interconnects by Spin-Etch Process; A Chemical Approach (2000).					
gag	AJ	Yongsik Moon, et al., Finishing of Advanced Ceramics and Glasses Symposium at the 101 st Annual Meeting of the American Ceramic Society, pgs. 269-279, "IDENTIFICATION OF THE MECHANICAL ASPECTS OF MATERIAL REMOVAL MECHANISMS IN CHEMICAL MECHANICAL POLISHING (CMP). (April 25-28, 1999).					
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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>gag</i>	AA	US 5, 866,031	2/2/1999	Carpio, et al.			5/12/2000
<i>gag</i>	AB	US 5,858,813	1/12/1999	Scherber, et al.			
<i>gag</i>	AC	US 5,922,091	7/13/1999	Tsai, et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
							X (abstract only)
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